

RECEIVED
CENTRAL FAX CENTER

APR 06 2004

OFFICIAL

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Confirmation No. 9635
Satoshi MAEMORI et al. : Docket No. 2001_1300A
Serial No. 09/955,111 : Group Art Unit 1752
Filed September 19, 2001 : Examiner Sin Lee

POSITIVE-WORKING PHOTORESIST
COMPOSITION AND PHOTSENSITIVE
MATERIAL USING SAME

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of
September 5, 2003.

The fee of \$950.00 is

- ☒ submitted herewith.
☐ to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.
☐ Small entity status of this application is established by a Small Entity Status Assertion which
☐ is enclosed.
☐ has been previously submitted.

Respectfully submitted,

Satoshi MAEMORI et al.

By Matthew M. Jacob
Matthew M. Jacob
Registration No. 25,154
Attorney for Applicants

MJ/da
Washington, D.C. 20006-1021
Telephone (202) 721-8200
Facsimile (202) 721-8250
March 4, 2004